

Supporting Information: Wide-angle tunable critical coupling in nanophotonic optical coatings with low-loss phase change material

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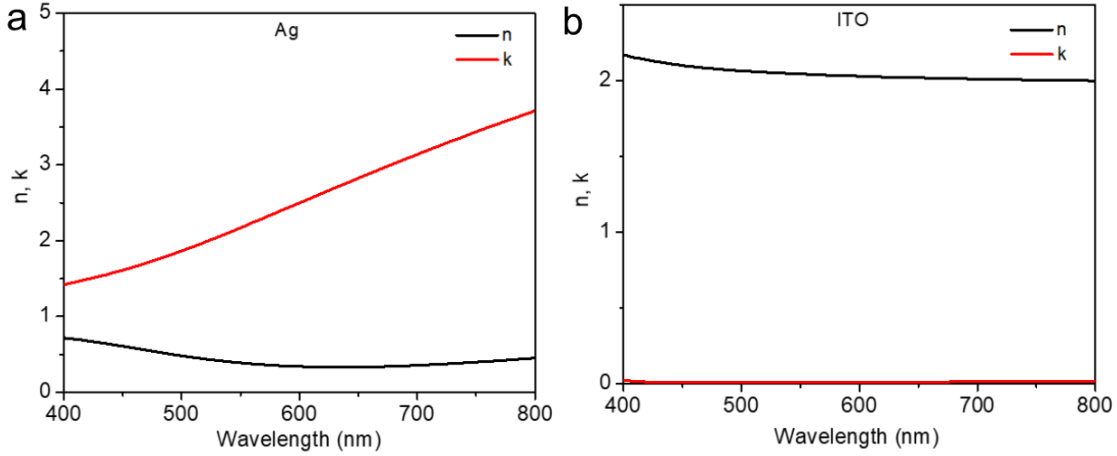


Figure S1 Measured optical constants of thin layers of Ag and ITO

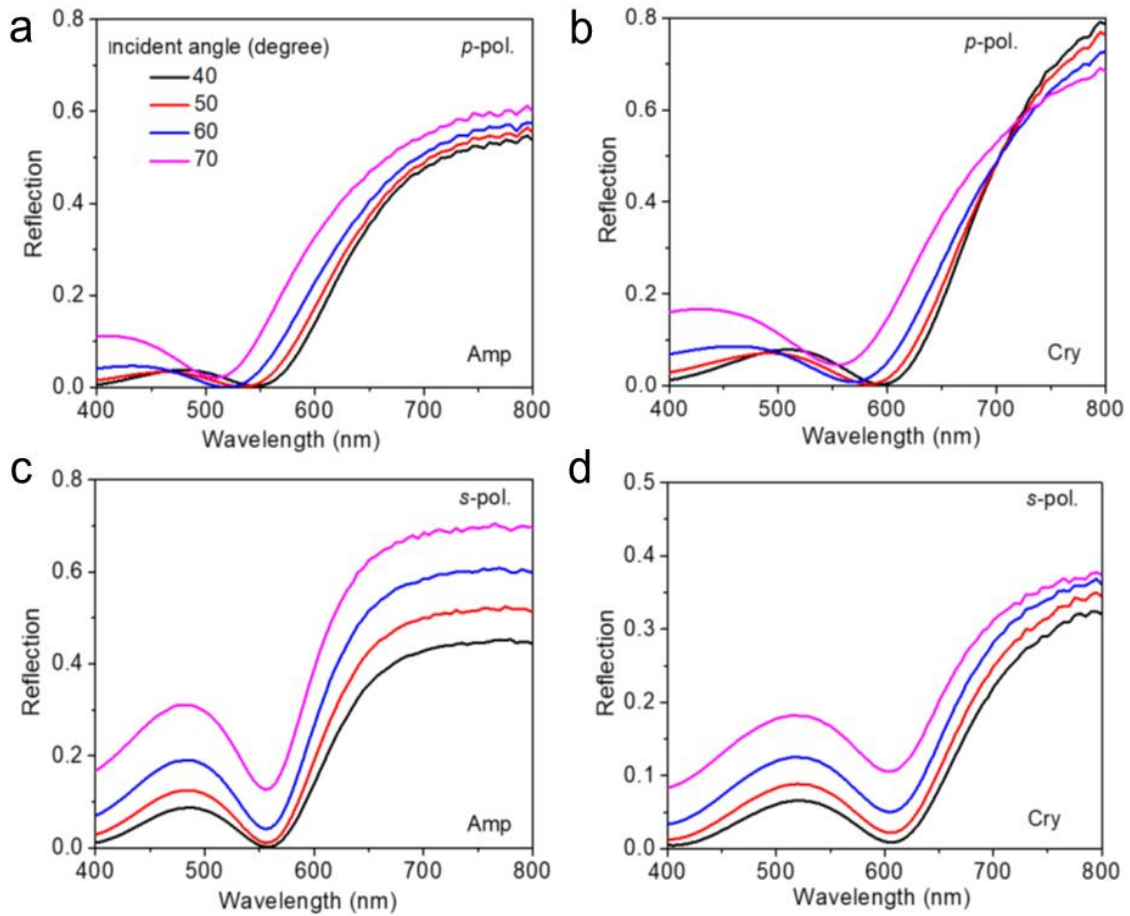


Figure S2 Measured angular reflection spectra of Ag/Sb₂S₃/ITO stack for (a) *p*-polarization and amorphous phase, (b) *p*-polarization and crystalline phase, (c) *s*-polarization and amorphous phase, and (d) *s*-polarization and crystalline phase

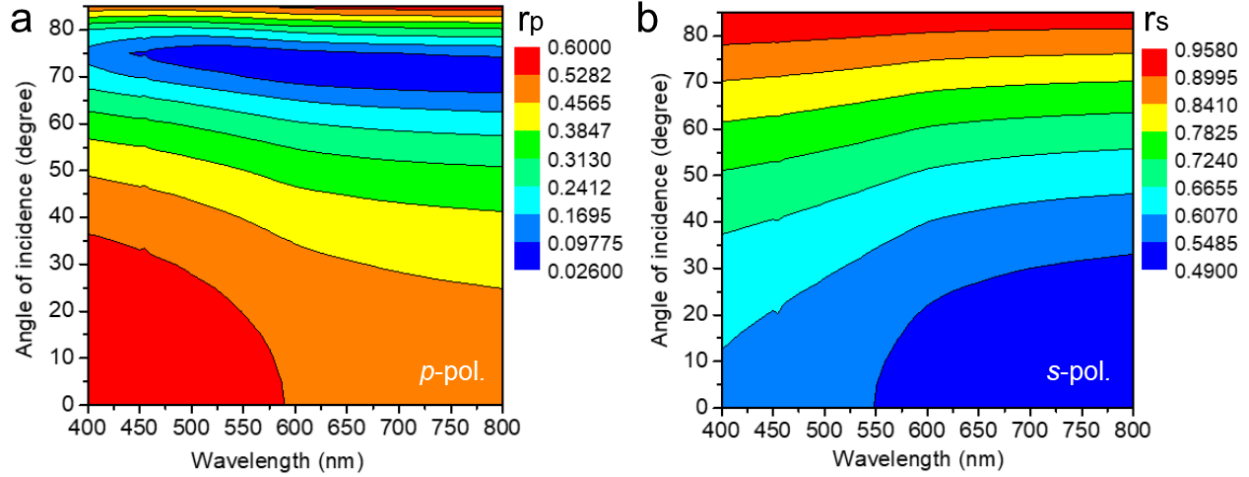


Figure S3 Calculated angle dependent Fresnel reflection coefficient at air/dielectric (Sb_2S_3) interface for (a) p -polarization and (b) s -polarization

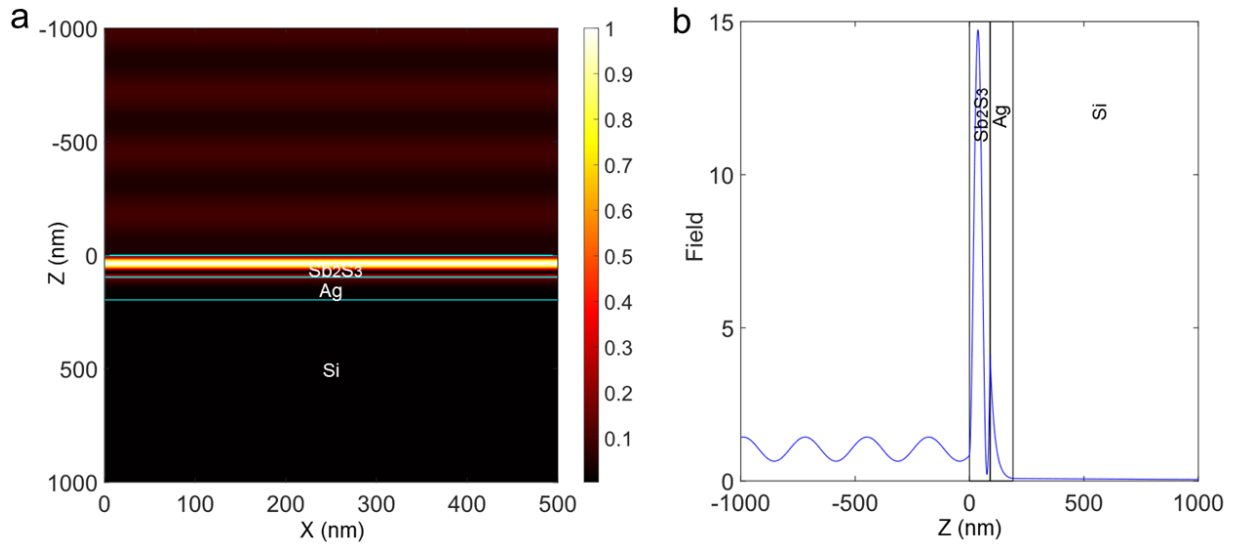


Figure S4 Simulated electric field distribution of Ag/ Sb_2S_3 (Amp) stack at normal incidence and 540 nm wavelength (a) 2D plot and (b) line plot along z -axis. Field is tightly confined inside the Sb_2S_3 cavity layer.

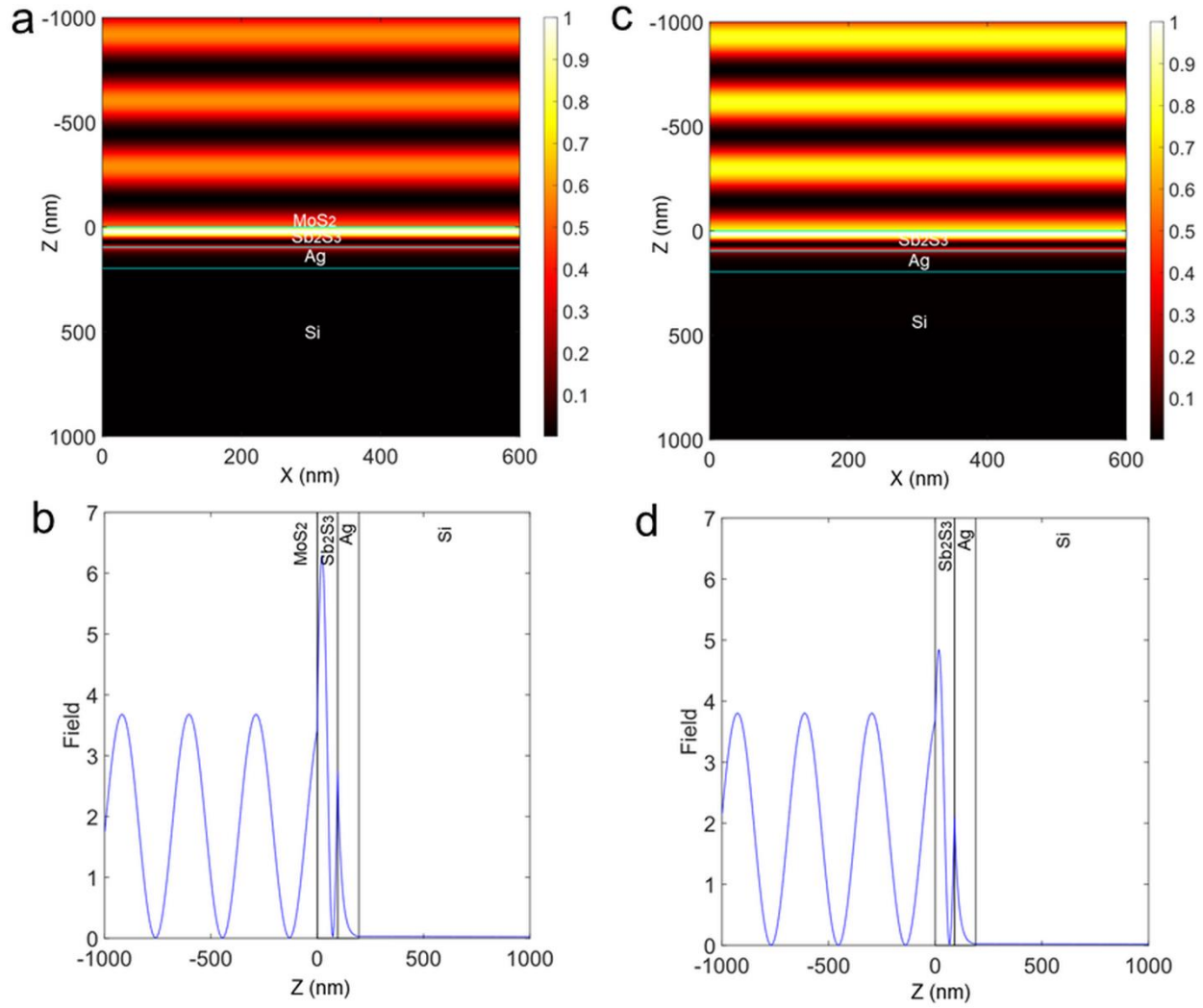


Figure S5 Simulated electric field distribution at normal incidence and 620 nm wavelength. With MoS₂ layer (a) 2D plot and (b) line plot along z-axis. Without MoS₂ layer (c) 2D plot and (d) line plot along z-axis. Field is enhanced in the presence of monolayer MoS₂.

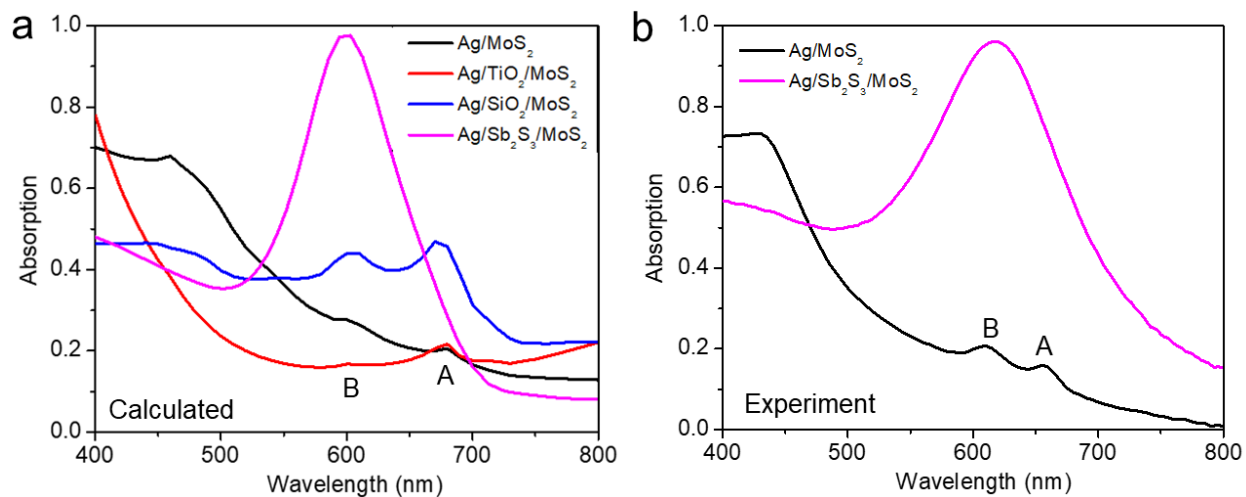


Figure S6 Absorption spectrum of MoS₂ on different substrates at normal incidence (a) Calculated (b) Experiment. The MoS₂ excitonic bands ‘A’ and ‘B’ are clearly visible on the spectra.

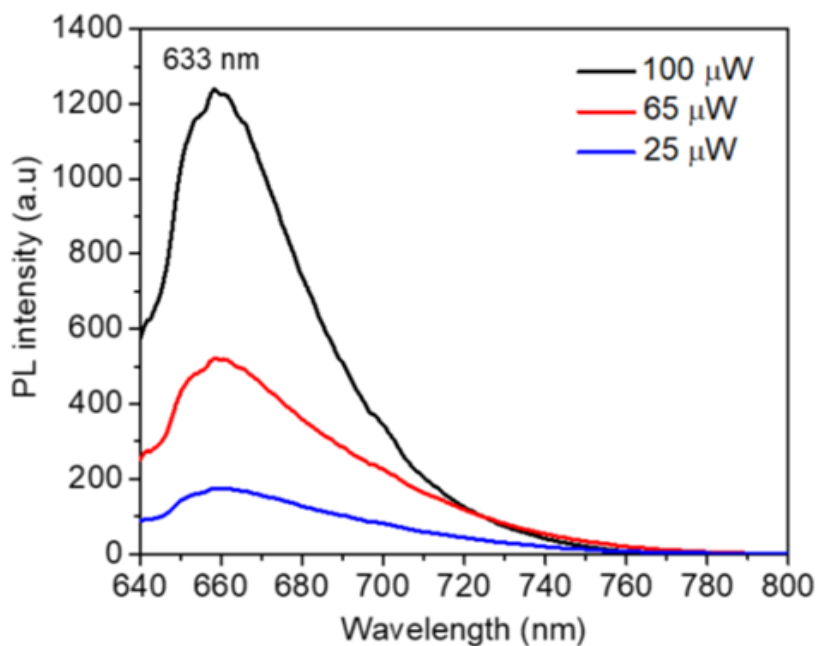


Figure S7 Measured PL intensity of Si/Ag/Sb₂S₃/MoS₂ stack for different laser power

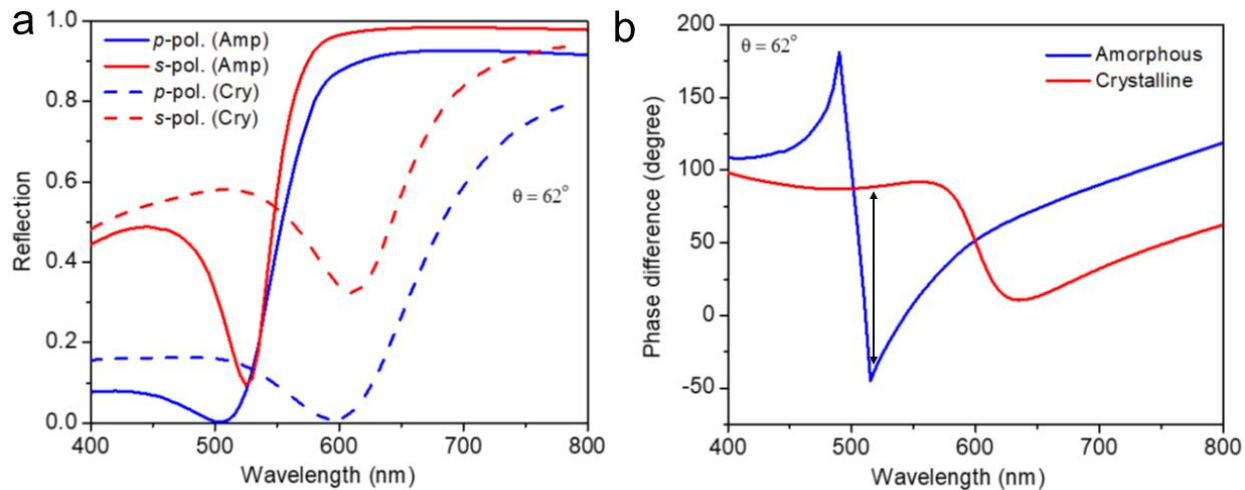


Figure S8 Calculated reflection and phase spectra at 62° angle of incidence (a) Reflection spectrum of Ag/Sb₂S₃/ITO stack in both amorphous and crystalline phases for *p*- and *s*-polarizations. (b) Phase spectra in both amorphous and crystalline phases.